



ATTORNEY DOCKET NO. 43890-485
PATENT

#6/Election
11/7/02
V8

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Hiroshi HAJI, et al.) Group Art Unit: 2823
Serial No.: 09/781,563) Examiner: GEORGE R. FOURSON
Filed: February 13, 2001)
For: METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE)

ELECTION UNDER 35 U.S.C. § 121

Hon. Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

In response to the restriction requirement set forth in the Office Action
mailed October 2, 2002, having a shortened statutory period for response set to expire
November 2, 2002, wherein the Examiner required restriction between the following
Species:

- Species I - wherein the first cutting is through the resin layer;
- Species II - wherein the first cutting is through the wafer;
- Species III - wherein the first cutting is forming grooves on the surface of
the wafer wherein devices are formed; and
- Species IV - wherein the backside of the wafer is ground followed by
forming grooves on the ground surface.

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Applicants elect without traverse Species II, with claims 1-7 readable thereon for initial prosecution on the merits.

Applicants believe that no extension of time is required. However, this conditional petition is being made to provide for the possibility that Applicants have inadvertently overlooked the need for a petition for extension of time. The Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment to Deposit Account No. 50-0417.

Respectfully submitted,

McDERMOTT WILL & EMERY

Date: 11/4/02

By: 

Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W. , Suite 1200
Washington, D.C. 20005-3096
Telephone: 202-756-8000
Facsimile: 202-756-8087

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